

Atty. Docket No. KIK01 P-322

#14C
Amend
S Davis
8/15/03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Art Unit : 2863
Examiner : Xiuqin Sun ✓
Appln. No. : 09/838,905 ✓
Applicant : Kenichiro Kobayashi
Filing Date : April 20, 2001 ✓
Confirmation No. : 1673
For : METHOD AND APPARATUS TO MEASURE AMOUNT OF
MOVEMENT USING GRANULAR SPECK PATTERN
GENERATED BY REFLECTING LASER BEAM

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Dear Sir:

AMENDMENT AFTER APPEAL UNDER 37 C.F.R. §1.116

Amendments to the claims are reflected in the listing of claims which begins on page
2 of this paper.

Remarks begin on page 6 of this paper.

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